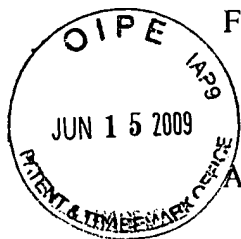


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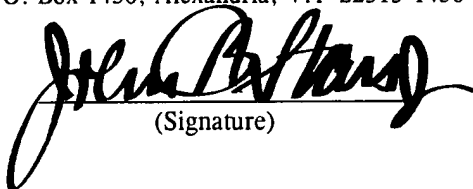
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA, et al.  
Serial No. : 10/526,205  
Filed : March 1, 2005  
For : ANODIC OXIDATION METHOD, TITANIUM  
OXIDE FILM MANUFACTURING METHOD  
AND CATALYST CARRYING METHOD  
Group Art Unit : 1742  
Examiner : William T. Leader  
Confirmation No. : 4976

Certificate of Mailing Under 37 CFR 1.8

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on June 9, 2009.

John B. Starr, Jr., Ph.D  
(Name)

  
(Signature)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action of 12 May 2009 requiring an election of inventions, applicant submits the Remarks presented below.